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CONFIRMATION NO. 6093

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| SERIAL NUMBER 10/773,026 | FILING OR 371(c) DATE 02/05/2004 RULE | CLASS 438 | GROUP ART UNIT 2813 | ATTORNEY DOCKET NO. 039153-0649 |
| APPLICANTS Qi Xiang, San Jose, CA; Paul R. Besser, Sunnyvale, CA; Minh Van Ngo, Fremont, CA; Eric N. Paton, Morgan Hill, CA; Haihong Wang, Fremont, CA; | | | | |
| ** CONTINUING DATA ***** None (HD) | | | | |
| ** FOREIGN APPLICATIONS ***** None (HD) | | | | |
| IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 05/05/2004 | | | | |
| Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after met <input type="checkbox"/> Allowance Verified and <u>12/05/04</u> Acknowledged <u>HD</u> Examiner's Signature Initials | | STATE OR COUNTRY CA | SHEETS DRAWING 8 | TOTAL CLAIMS 19 INDEPENDENT CLAIMS 3 |
| ADDRESS 34083 | | | | |
| TITLE Fully depleted strained semiconductor on insulator transistor and method of making the same | | | | |
| FILING FEE RECEIVED 770 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | |